

Notice of References Cited	Application/Control No. 10/796,427		Applicant(s)/Patent Under Reexamination LIN ET AL.	
	Examiner MONICA LEWIS		Art Unit 2822	Page 1 of 1

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*	B	US-6,963,138	11-2005	Low et al.	257/760
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NON-PATENT DOCUMENTS

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	V	Van Zant, Microchip Fabrication, 2000, McGraw-Hill, pages 300-302.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.